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** CONTINUING DATA *****

** FOREIGN APPLICATIONS *****

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| Foreign Priority claimed <input type="checkbox"/> yes <input type="checkbox"/> no | STATE OR | SHEETS | TOTAL | INDEPENDENT |
| 35 USC 119 (a-d) conditions met <input type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance | COUNTRY | DRAWING | CLAIMS | CLAIMS |
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| Examiner's Signature | Initials | | | |

ADDRESS

20277

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TITLE

METHOD OF MANUFACTURING A SEMICONDUCTOR DEVICE WITH PENETRATION ELECTRODES THAT
PROTRUDE FROM A REAR SIDE OF A SUBSTRATE FORMED BY THINNING THE SUBSTRATE

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| FILING FEE | FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT | <input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) |
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